## Paper / Subject Code: 32505 / Elective - I Advanced Sensors

T.E.(Instrumentation Engineering)(SEM-V)(Choice Base) / Nov 2019 / 27.11.2019

## [Time: Three Hours]

[ Marks:80]

N.B:

- 1. Question.No.1 is compulsory.
- 2. Attempt any three questions from remaining the questions.
- 3. Assume suitable data wherever necessary.

1.	Answer the following		20
	a)	Explain working principle of any one optical chemical sensor.	
	b)	Explain working principle of ADXL345 digital accelerometer.	
	c)	Explain any one etching technique used in MEMS fabrication.	
	d)	Explain optical method of dissolved oxygen measurement.	
2.	a)	List various types of sensors based on Chemical transduction principle and explain any two.	10
	b)	Explain various techniques of deposition for MEMS sensor fabrication.	10
3.	a)	Give comparative study of thermal sensors.	10
	b)	Explain lift-off fabrication technique in detail.	10
4.	a)	List various ADCs used for sensor signal conditioning and explain any one in detail.	10
	b)	Explain digital humidity and temperature DHT sensor.	10
5.	a)	Explain smart analog IC 500 in detail.	10
	b)	List various mechanical sensors and explain application of any one sensor in detail.	10
6.	W	Write short note on any two:	
	a)	Sensors for soil moisture measurement	
	b)	Photolithography	
	c)	Carbon Dioxide Measurement	

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